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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Akira IZUMI

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For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING
METHOD DRYING SUBSTRATE BY SPRAYING GAS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same
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Respectfully submitted,

Max Moskowitz

Name of applicant, assignee or
Registered Representative

Signature

November 11, 2003

Date of Signature

Max Moskowitz

Registration No.: 30,576

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700

MM:nb
Enclosures